## IAP12 Rec'd PCT/PTO 1 8 SEP 2006

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Mitsunori TAKESHITA, et al.

Serial Number: Not Yet Assigned

(§371 of International Application PCT/JP05/11714)

Filed: September 18, 2006

SUBSTRATE PROCESSING APPARATUS AND MANUFACTURING

METHOD FOR A SEMICONDUCTOR DEVICE

## **INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

September 18, 2006

Sir:

For:

In compliance with 37 CFR 1.56, Applicants call to the attention of the Patent and Trademark Office the references listed on the attached PTO-1449 and cited in the enclosed international search report. References AE-AI are cited in the international search report.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please charge Deposit Account No. <u>01-2340</u>.

Respectfully submitted, ARMSTRONG, KRATZ, QUINTOS, HANSON & BROOKS, LLP

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Enclosures: PTO-1449; References (5); International Search Report

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INFORMATION			Atty. Do	60711		Serial No. New Application					
DISCLOSURE STATEMENT		Applicant(s): Mitsunori AKESHITA, et al.									
PTO-1449			Filing Date: September 18, 2006				Group Art Unit: Not Yet Assigned				
U.S. PATENT DOCUMENTS											
Examiner Initial		Docum	ent No.	Name	Dat	e	Class	Subclass	Filing Date (If appropriate)		
	AA										
	AB										
	AC										
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	Document No.	Date	Country	Translation (Yes or No)
 AE	10-242232	09/11/98	Japan	Yes-Abstract
 AF	7-130721	05/19/95	Japan	Yes-Abstract
 AG	7-297257	11/10/95	Japan	Yes-Abstract
 AH	2003-92329	03/28/03	Japan	Yes-Abstract
 AI	2003-7800	01/10/03	Japan	Yes-Abstract

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Examiner

Date Considered